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UNITED STATES PATENT AND TRADEMARK OFFICE

PR-59

Applicant : Karl-Hermann Busse, et al
Serial No. : 10/798,239
Filed : March 10, 2004
For : MOBILE TRANSPORTABLE ELECTROSTATIC
SUBSTRATE HOLDER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

S I R:

The attention of the Examiner and of the Patent and Trademark Office is hereby directed to the references listed on attached form PTO-1449. Copies of the references are forwarded herewith.

The relevance of the references is discussed in the specification.

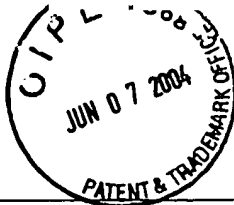
Respectfully submitted,

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FK:ml
Encls: PTO-1449
w/seven (7) references

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on June 3, 2004

By: Friedrich Kueffner Date: June 3, 2004
Friedrich Kueffner

Sheet 1 of 1

Form PTO-1449		Docket No.: PR-59		Serial No.: 10/798,239				
LIST OF PRIOR ART CITED BY APPLICANT		Applicant: Karl-Hermann Busse, et al						
		Filing Date: March 10, 2004		Group:				
U.S. PATENT DOCUMENTS								
Exam. Init.		Document Number	Date	NAME	Class	Subclass	Filing Date if appropriate	
	AA							
	AB							
	AC							
	AD							
	AF							
U.S. PATENT APPLICATION PUBLICATION								
Exam. Init.		Document Number	Date	NAME	Class	Subclass	Filing Date if appropriate	
	AG	2002/0110449	8/02	ARIT ET AL				
	AH							
	AI							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	COUNTRY	Class	Subclass	TRANSLATION Yes No	
	AJ	1 2 1 7 6 5 5	6/02	EUROPEAN				X
	AK	0 2 1 1 1 8 4	2/02	W I P O				X
	AL							
	AN							
	AO							
OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AP	SHERMAN ET AL., SEMICONDUCTOR INTERNATIONAL V 20 JULY 1997, 319-321						
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	AR	WATANABE ET AL., JPN. J. APPLI. PHYS. VOL. (32) 1993, 864-871						
	AS	HARTSOUGH: SOLID-STATE TECHNOLOGY, JANUARY 1993, 87-90						
EXAMINER					DATE CONSIDERED			